



# Structural properties of $\text{In}_2\text{Se}_3$ precursor layers deposited by spray pyrolysis and physical vapor deposition for $\text{CuInSe}_2$ thin-film solar cell applications



P. Reyes-Figueroa<sup>a,b</sup>, T. Painchaud<sup>b</sup>, T. Lepetit<sup>b</sup>, S. Harel<sup>b</sup>, L. Arzel<sup>b</sup>, Junsin Yi<sup>c,\*</sup>, N. Barreau<sup>b</sup>, S. Velumani<sup>a,c,\*</sup>

<sup>a</sup> Department of Electrical Engineering (SEES), Cinvestav-Zacatenco, 2508 Av. IPN, 07360 Mexico City, Mexico

<sup>b</sup> IMN, UMR 6502, Université de Nantes, 2 rue de la Houssinière, 44322 Nantes Cedex 3, France

<sup>c</sup> School of Information and Communication Engineering, 2066 Seobu-ro, Jangnan-gu, 440-746 Suwon, Republic of Korea

## ARTICLE INFO

Available online 28 January 2015

### Keywords:

Indium selenide  
Copper indium selenide  
Spray pyrolysis  
Physical vapor deposition

## ABSTRACT

The structural properties of  $\text{In}_2\text{Se}_3$  precursor thin films grown by chemical spray pyrolysis (CSP) and physical vapor deposition (PVD) methods were compared. This is to investigate the feasibility to substitute PVD process of  $\text{CuInSe}_2$  (CISE) films by CSP films as precursor layer, thus decreasing the production cost by increasing material-utilization efficiency. Both films of 1  $\mu\text{m}$  thickness were deposited at the same substrate temperature of 380 °C. X-ray diffraction and Raman spectra confirm the formation of  $\gamma\text{-In}_2\text{Se}_3$  crystalline phase for both films. The PVD and CSP films exhibited (110) and (006) preferred orientations, respectively. The PVD films showed a smaller full width at half maximum value (0.09°) compared with CSP layers (0.1°). Films with the same crystalline phase but with different orientations are normally used in the preparation of high quality CISE films by 3-stage process. Scanning electron microscope cross-section images showed an important difference in grain size with well-defined larger grains of size 1–2  $\mu\text{m}$  in the PVD films as compared to CSP layers (600 nm). Another important characteristic that differentiates the two precursor films is the oxygen contamination. X-ray photoelectron spectroscopy showed the presence of oxygen in CSP films. The oxygen atoms could be bonded to indium by replacing Se vacancies, which are formed during CSP deposition. Taking account of the obtained results, such CSP films can be used as precursor layer in a PVD process in order to produce CISE absorber films.

© 2015 Elsevier B.V. All rights reserved.

## 1. Introduction

$\text{CuInSe}_2$  (CISE) and  $\text{Cu}(\text{In,Ga})\text{Se}_2$  (CIGSe) materials are widely investigated as absorber layers in thin film solar cells. This is mainly due to their high absorption coefficient ( $10^{-5} \text{ cm}^{-1}$ ), suitable direct band gap (~1–1.7 eV) and potential low-cost production [1]. Furthermore, CISE and CIGSe solar cells exhibit very good outdoor stability and radiation hardness [2]. In particular, CIGSe thin film solar cells have achieved efficiencies of 20.8% [3]. This efficiency surpasses the best achieved results of multicrystalline silicon and CdTe solar cells [4].  $\text{Cu}(\text{In,Ga})\text{Se}_2$  films can be deposited by vacuum and non-vacuum methods such as physical vapor deposition (PVD) (e.g. co-evaporation) [5,6], selenization of metal precursor films [7], electrodeposition [8], particulate process (e.g. spin coating, doctor blade) [9–12], and chemical spray pyrolysis (CSP) [13–16].

Non-vacuum deposition methods of CISE have shown significantly lower capital expenditure, reduced material cost and produce devices

with considerable efficiencies [14,17,18]. Amongst these methods, the chemical spray pyrolysis deposition has the advantages of low cost equipment, easy scale-up, simple atomization process and temperature control. This deposition is based on the pyrolytic decomposition of small droplets of chloride-based solution sprayed onto a heated substrate under atmospheric conditions [19]. The PVD by co-evaporation method gives the best solar cell efficiencies but poses cost and technological barriers. In this technique, vapors of two different materials are generated simultaneously. These two vapors condense together to form an alloy or a compound. Amongst the different co-evaporation processes, the so-called “3-stage” is essential in obtaining high quality CISE films [20]. This process basically consists of Stage-1: growth of a 1  $\mu\text{m}$  thick  $\text{In}_2\text{Se}_3$  thin film at low temperature (300–400 °C), Stage-2: these layers are used as precursor during the co-evaporation of copper and selenium, where a Cu-rich film is yielded, Stage-3: indium and selenium are co-evaporated and the film evolves gradually to Cu-poor until the final composition is reached [21]. The  $\text{In}_2\text{Se}_3$  precursor films used in this process are very important because of i) their direct relationship with the final CISE/CIGSe absorber material quality [22] and ii) its deposition represents around 50% of the total deposition material in a standard 3-stage process [6]. The  $\text{In}_2\text{Se}_3$  is a III<sub>2</sub>–VI<sub>3</sub> semiconductor

\* Corresponding authors at: Department of Electrical Engineering (SEES), Cinvestav-Zacatenco, 2508 Av. IPN, 07360 Mexico City, Mexico. Tel.: +52 55 57 47 38 00x2036.  
E-mail addresses: [yi@skku.ac.kr](mailto:yi@skku.ac.kr) (J. Yi), [velu@cinvestav.mx](mailto:velu@cinvestav.mx) (S. Velumani).

compound that exhibits several phases and crystalline structures (e.g. defected hexagonal, cubic) depending on the deposition conditions.

In this research work, we investigated the feasibility of obtaining CISe films by PVD (e.g. co-evaporation 3-stage) using CSP film as precursor layer by focusing on the structural properties of the  $\text{In}_2\text{Se}_3$  precursor films obtained from CSP and PVD. This approach could lead to decreased CISe film production cost by increasing the material-utilization efficiency.

## 2. Experimental details

### 2.1. Deposition of $\text{In}_2\text{Se}_3$ thin films

$\text{In}_2\text{Se}_3$  thin films were deposited by PVD and CSP in order to study the difference in the structural properties of the films. A standard 3-stage co-evaporation process uses 1  $\mu\text{m}$  thick  $\text{In}_2\text{Se}_3$  precursor films deposited at 300–400 °C in order to obtain high quality CISe absorbers [6,22]. For this reason, both PVD and CSP  $\text{In}_2\text{Se}_3$  layers used in this work were deposited at 380 °C with 1  $\mu\text{m}$  thickness.

#### 2.1.1. Chemical spray pyrolysis process

The  $\text{In}_2\text{Se}_3$  layers were deposited by CSP on molybdenum coated soda lime glass (SLG) substrates. The CSP films were grown on a molten tin bath at 380 °C. The substrate temperature was monitored by a thermocouple located at the backside of the glass substrate. The details of the CSP setup are described elsewhere [16]. The precursor solutions contain concentrations of 0.0015 M for  $\text{InCl}_3$  and 0.0055 M for N-N-dimethyl-selenourea (DMSeU) in a 20% volume ethanol aqueous solution. DMSeU was provided in excess of stoichiometry due to the volatile nature of Se at the deposition temperature. The desired pH (4–5) of the solution was achieved by addition of HCl. The total volume of the solution sprayed was 800 ml with a spray rate of 6.5 ml/min with nitrogen as a carrier gas whose flow rate was 1.5 l/min. These parameters yield films of about 1  $\mu\text{m}$  thickness.

#### 2.1.2. Physical vapor deposition process

The  $\text{In}_2\text{Se}_3$  films of 1  $\mu\text{m}$  thickness were deposited onto Mo/SLG substrates. The elemental fluxes of In and Se were controlled by changing the temperatures of the evaporation sources. A quartz oscillator was used in order to control the evaporation rates and thickness of the film. During the deposition, the substrates were heated by an infrared source. The temperature was monitored by a thermocouple located at the backside of the substrate. The deposition were carried out at a substrate temperature of 380 °C under high vacuum ( $1 \times 10^{-4}$  Pa). An effusion cell evaporation source for In and pyrex crucible for Se were used. During the evaporation process, the temperature of In and Se sources were kept at 1010 °C and 285 °C, respectively.

### 2.2. Thin film characterization

The morphology of the films was observed by scanning electron microscope (SEM)-model JEOL 7600F using an acceleration voltage of 5 kV with a magnification of  $\times 20,000$ . The average composition of the films was measured by electron dispersive spectroscopy (EDS) using a SEM equipped with an energy dispersive spectrometer SDD SAMx with a resolution of 129 eV, employing a beam current of 0.3 nA and an acceleration voltage of 20 kV. The crystalline quality and orientation were characterized by X-ray diffraction (XRD) using a  $\text{Cu-K}\alpha$  radiation (1.541 Å) with a  $\theta/2\theta$  configuration and stepsize of 0.01°. Raman measurements were performed with a Jobin-Yvon T64000 using an argon laser ( $\lambda = 514.5$  nm) with a probe area around 1  $\mu\text{m}^2$  for an acquisition time of 5 min. The surface analyses were performed by X-ray photoemission spectroscopy (XPS) in a Kratos Axis Nova with a monochromatic Al K radiation (1486.6 eV) and 160 eV pass energy with an energy step of 0.5 eV. The sputtering was performed for 60 s with an Ar ion beam and beam energy of 300 eV. The C1s signal from

adventitious carbon with a binding energy  $E_B = 284.6$  eV was used for energy referencing. The peak fit analysis was performed using the CasaXPS software where a linear background was subtracted from the spectra. The spectra were fitted by peaks with a Gauss (60%)–Lorentz (40%) profiles.

## 3. Results and discussion

### 3.1. $\text{In}_2\text{Se}_3$ thin films grown by PVD

The PVD films were studied by XRD in order to determine their crystalline properties. Fig. 1 shows the diffractogram of PVD- $\text{In}_2\text{Se}_3$  thin film grown on Mo/SLG. The films exhibited diffraction peaks corresponding to polycrystalline  $\gamma$ - $\text{In}_2\text{Se}_3$ . The films have shown (110) orientation with strong (300) and weak (006) lines. This result is in good agreement with the XRD pattern of  $\gamma$ - $\text{In}_2\text{Se}_3$  (JCPDS 40-1407) with hexagonal structure [23]. Peaks around 38° and 48° are related to  $\beta$ - $\text{In}_2\text{Se}_3$  phase. The peak around 19° does not match with InSe or  $\beta$ - $\text{In}_2\text{Se}_3$  phases. The full width half maximum (FWHM) of the (110), (006) and (300) peaks were 0.07, 0.09 and 0.10°, respectively.

The Raman spectrum of the PVD film is shown in Fig. 2a. The main mode located at 149.4  $\text{cm}^{-1}$  is related to the formation of a stable polycrystalline  $\gamma$ - $\text{In}_2\text{Se}_3$  phase [24]. The Raman modes located around 178 and 203  $\text{cm}^{-1}$  are related to both  $\gamma$ - $\text{In}_2\text{Se}_3$  [24] and  $\alpha$ - $\text{In}_2\text{Se}_3$  [25]. The vibrational modes located at around 149 and 227  $\text{cm}^{-1}$  appear at the same wave number reported by Wanatabe and Marsillac et al. [26,27]. This result is consistent with the XRD diffraction measurements.

The surface morphology and cross-section SEM images of PVD  $\text{In}_2\text{Se}_3$  films are shown in Fig. 3a,b. Surface morphology shows lamellar structures with different grain sizes and also hexagonal grains with 1–2  $\mu\text{m}$  width. These hexagonal grains are related to the growth of the films with (001) orientation. The cross-section image (Fig. 3a) exhibited densely packed columnar structure (~0.8–1  $\mu\text{m}$ ). The observed morphologies were attributed to the high surface mobility of adatoms impinging on the surface of the substrate during nucleation stage. The relative chemical composition of the PVD- $\text{In}_2\text{Se}_3$  film without considering the oxygen content is shown in Table 1.

The surface of the PVD- $\text{In}_2\text{Se}_3$  films was studied by XPS. Fig. 4 shows the O1s core level spectra recorded from un-clean and ion sputtered surface of PVD films. The O1s peak obtained from un-clean surface

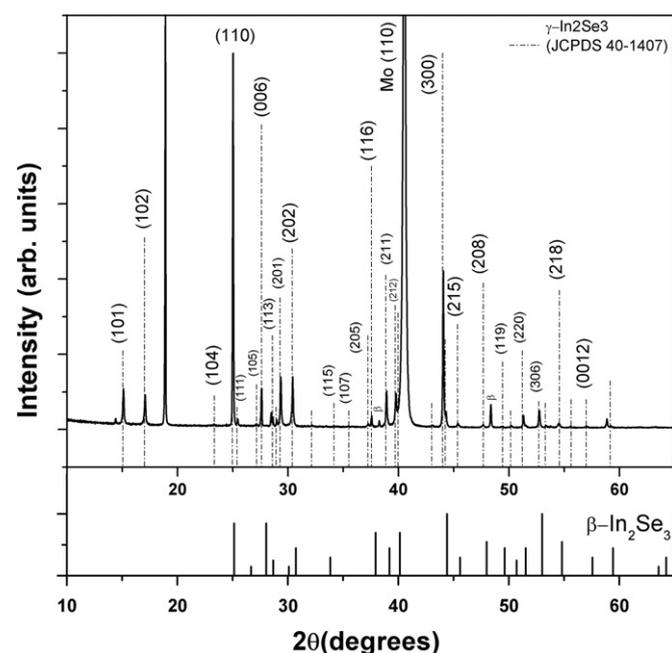


Fig. 1. XRD pattern of the  $\text{In}_2\text{Se}_3$  film grown by PVD.

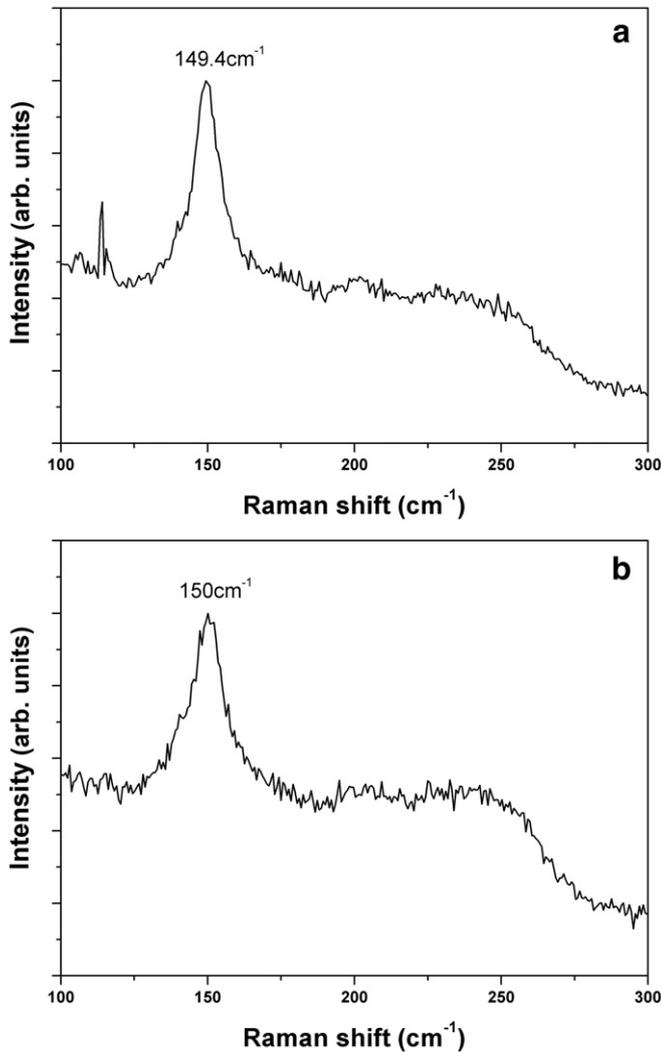


Fig. 2. Raman spectroscopy of the  $\text{In}_2\text{Se}_3$  film grown by PVD (a) and CSP (b) techniques.

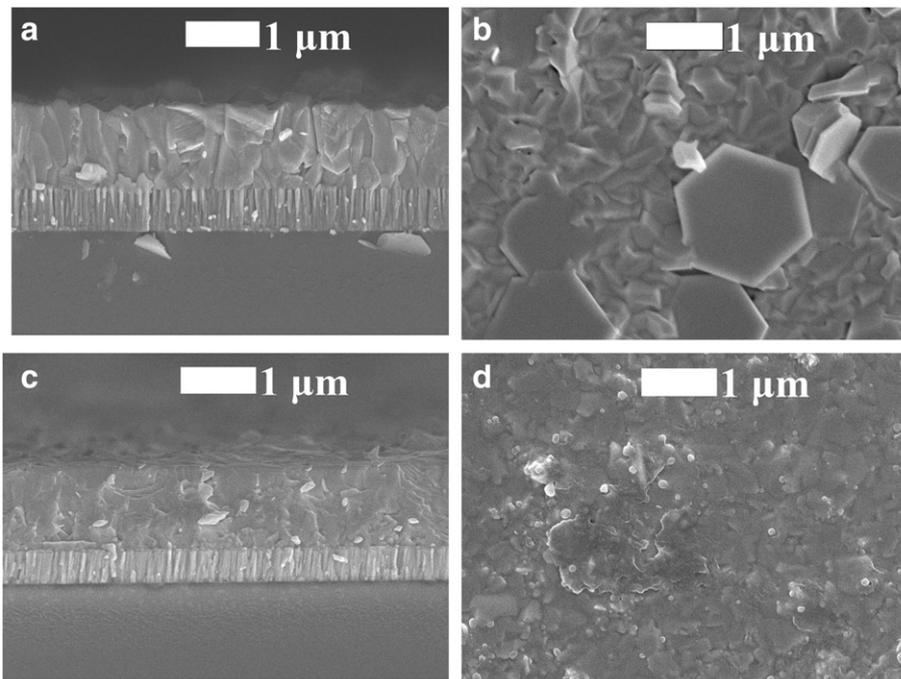


Fig. 3. SEM images of the  $\text{In}_2\text{Se}_3$  film grown by PVD (a,b) and CSP (c,d) techniques.

could be separated into at least two sub-bands located at 531.28 and 529.76 eV. The peak at higher binding energy (BE) is characteristic of surface contaminated by oxygen from air. The peak at lower BE could be corresponding to the oxygen bonded to a metal [28]. After ion sputtering almost all the O1s peak signal is lost and the remaining peak is situated at 529.9 eV, corresponding to a portion of oxygen content still bonded to the metal.

### 3.2. $\text{In}_2\text{Se}_3$ thin films grown by CSP

Fig. 5 shows the XRD of the CSP- $\text{In}_2\text{Se}_3$  thin film grown on Mo/SLG. Similar to PVD films, the CSP film exhibited diffraction peaks related to polycrystalline  $\gamma\text{-In}_2\text{Se}_3$  phase. This is in good agreement with the XRD pattern of  $\gamma\text{-In}_2\text{Se}_3$  (JCPDS 40-1407) with hexagonal structure [23]. Contrary to the (110)-oriented PVD films, the CSP film exhibited (006) orientation with weak (110) and (300) lines. In results reported by Mise et al. [22] it is observed that  $\text{Cu}(\text{In,Ga})\text{Se}_2$  films with same (112) orientation are obtained by using a (110) or (006)-oriented  $\text{In}_2\text{Se}_3$  precursor films. It is known that during the CSP deposition, the substrate temperature of the front surface is lower (15–20 °C) than the back of the substrate where the thermocouple is located [29]. This decrease is due to the difference in temperature of the sprayed precursor solution (15–25 °C) and the substrate temperature (380 °C). Thus, the substrate temperature during CSP deposition is lower than 380 °C. Thus, one reason for the change in orientation could be the lower growth temperature used in the CSP deposition as compared to the PVD. Mise et al. [22] have reported a similar behavior of  $(\text{In,Ga})_2\text{Se}_3$  films. The difference in temperature is also present in the CVD process but, given that the precursor materials reaching the substrate are evaporated at relative high temperatures (1010 °C and 285 °C), the difference is less than in CSP deposition. Another reason for the (006)-dominant peak obtained by CSP film could be the formation of a Se-deficient  $\text{In}_2\text{Se}_3$  phase. The chemical composition of the CSP- $\text{In}_2\text{Se}_3$  layer is shown in Table 1. The composition of both PVD and CSP films is slightly different. The Se/In ratio is observed to be lower in the CSP deposited films. This could be related to the re-evaporation of Se from the hot substrate in the open-air atmosphere. Thus, it is possible to assume the formation of more Se vacancies in the CSP films. These results are in good agreement



#### 4. Conclusion

In this study, we showed that  $\text{In}_2\text{Se}_3$  precursor thin films with similar structural properties and good uniformity could be deposited by CSP and PVD techniques. XRD and Raman spectroscopy showed that both films have same  $\gamma\text{-In}_2\text{Se}_3$  crystalline phase. The PVD and CSP films exhibited a (110) and (006) preferred orientation, respectively. Both orientations, however, are related with CIGSe/CIGS films with the same (112) preferential orientation. SEM images showed smaller grains in the CSP films compared to PVD layers. In a three-stage process involving the two CSP (first step) and PVD (second and third step) techniques, a higher number of GBs in the CSP- $\text{In}_2\text{Se}_3$  film could result in an effective grain growth of the final absorber layer. Another important characteristic that differentiates both precursor films is the oxygen contamination, which could be beneficial or detrimental to the electrical properties of the CIGSe based solar cell depending on its location. A chemical treatment of CSP  $\text{In}_2\text{Se}_3$  films could be necessary in order to avoid detrimental effects of oxygen. Taking account of the obtained results, we suggest that the CSP films could be considered as precursor layer in a co-evaporation 3-stage process in order to produce CIGSe absorber films.

#### Acknowledgments

The authors would like to thank to the members of our research group in Université de Nantes (IMN) and Cinvestav-Zacatenco. This work is supported by the Consejo Nacional de Ciencia y Tecnología (grant 219494) and Université de Nantes (grant 219494). One of the authors (SV) wishes to thank the support from MSIP (Ministry of Science, Ict & future Planning) (141S-6-3-0641), South Korea.

#### References

- [1] K.L. Chopra, P.D. Paulson, V. Dutta, Thin-films solar cells: an overview, *Prog. Photovolt.* 12 (2004) 69.
- [2] L. Ying, K. Deyi, Preparation of  $\text{Cu}(\text{In,Ga})\text{Se}_2$  thin film by non-vacuum mechanochemical and spin coating, IEEE Asia-Pacific Power and Energy Engineering Conference, Wuhan, China, March 25–28, 2011.
- [3] P. Jackson, D. Hariskos, R. Wuerz, W. Wischmann, M. Powalla, Compositional investigation of potassium doped  $\text{Cu}(\text{In,Ga})\text{Se}_2$  solar cells with efficiencies up to 20.8%, *Phys. Status Solidi (RRL)* 8 (3) (2014) 219.
- [4] M.A. Green, K. Emery, Y. Hishikawa, W. Warta, E.D. Dunlop, *Prog. Photovolt. Res. Appl.* 22 (2014) 1.
- [5] I. Repins, M.A. Contreras, B. Egaas, C. DeHart, J. Scharf, C.L. Perkins, B. Noufi, 19.9 efficient  $\text{ZnO}/\text{CdS}/\text{CIGS}$  solar cells with 81.2% fill factor, *Prog. Photovolt. Res. Appl.* 16 (2008) 235.
- [6] N. Barreau, J. Lahnemann, F. Couzinié-Devy, L. Assmann, P. Bertoncini, J. Kessler, Impact of Cu-rich growth on the  $\text{CuIn}_{1-x}\text{Ga}_x\text{Se}_2$  surface morphology and related solar cells behaviour, *Sol. Energy Mater. Sol. Cells* 93 (2009) 2013.
- [7] K. Kushiya, T. Komaru, Y. Nakayama, T. Kume, Y. Suzuki, Technical Digest of 17th Photovoltaic Science and Engineering Conference, Fukuoka, Japan, December 3–7, 2007, p. 1796.
- [8] M.E. Calixto, K.D. Dobson, B.E. McCandless, R.W. Birkmire, Growth mechanisms of electrodeposited  $\text{CuInSe}_2$  and  $\text{Cu}(\text{In,Ga})\text{Se}_2$  determined by cyclic voltammetry, Materials Research Society Proceedings, Thin-Film Compound Semiconductor Photovoltaics Symposium, vol. 865, 2005, p. F14.17.1.
- [9] M.G. Panthani, V. Akhavan, B. Goodfellow, J. Schmidtko, L. Dunn, A. Dodabalapur, P.F. Barbara, B.A. Korgel, Synthesis of  $\text{CuInS}$ ,  $\text{CuInSe}$  and  $\text{Cu}(\text{In,Ga})\text{Se}$  (CIGS) nanocrystal “inks” for printable photovoltaics, *J. Am. Chem. Soc.* 130 (49) (2008) 16770.
- [10] D.L. Shulz, C.J. Curtis, A. Cram, J.L. Alleman, A. Mason, R.J. Matson, J.D. Perkins, D.S. Ginley, CIGS films via nanoparticle spray deposition: attempts at densifying a porous precursor, Conference Record of the 26th IEEE Photovoltaic Specialist Conference, California, USA, Sept–Oct 29–3, 1997, p. 483.
- [11] B. Vidhya, S. Velumani, J.A. Arenas-Alatorre, A. Morales-Acevedo, R. Asomoza, J.A. Chavez-Carvayar, Structural studies of mechano-chemically synthesized  $\text{CuIn}_{1-x}\text{Ga}_x\text{Se}_2$  nanoparticles, *Mater. Sci. Eng. B* 174 (2010) 216.
- [12] B. Vidhya, S. Velumani, R. Asomoza, Effect of milling time and heat treatment on the composition of  $\text{CuIn}_{0.75}\text{Ga}_{0.25}\text{Se}_2$  nanoparticles precursors and films, *J. Nanoparticle Res.* 13 (2011) 3033.
- [13] C.R. Abernathy, C.W. Bates, A.A. Anani, B. Haba, G. Smestad, Production of single phase chalcopyrite  $\text{CuInSe}_2$  by spray pyrolysis, *Appl. Phys. Lett.* 45 (2) (1984) 890.
- [14] S. Duchemin, J. Bougnot, A. El Ghzizal, K. Belghit, Studies on the improvement of sprayed  $\text{CdS}-\text{CuInSe}_2$  solar cells, Proceedings of the 9th European Photovoltaic Solar Energy Conference, Freiburg, September 25–29, 1989, p. 476.
- [15] B.J. Babu, S. Velumani, R. Asomoza, An (ITO or AZO)/ $\text{ZnO}/\text{Cu}(\text{In}_{1-x}\text{Ga}_x)\text{Se}_2$  superstrate thin film solar cell structure prepared by spray pyrolysis, 37th IEEE Photovoltaic Specialist Conference, Washington, USA, June 19–24, 2011, p. 1238.
- [16] B.J. Babu, S. Velumani, A. Morales-Acevedo, R. Asomoza, Properties of  $\text{CuInGaSe}$  thin films prepared by chemical spray pyrolysis, 7th International Conference on Electrical Engineering, Computing Science and Automatic Control, Chiapas, Mexico, September 8–10, 2010, p. 582.
- [17] B.M. Basol, M. Pinarbasi, S. Aksu, J. Wang, Y. Matus, T. Johnson, Y. Matus, B. Metin, M. Narasimhan, D. Nayak, G. Norsworthy, D. Soltz, J. Wang, T. Wang, H. Zolla, Electroplating based technology for roll-to-roll manufacturing, 23rd European Photovoltaic Solar Energy Conference, Valencia, Spain, September 1–5, 2008, p. 2137.
- [18] B.M. Basol, Low cost techniques for the preparation of  $\text{Cu}(\text{In,Ga})(\text{Se,S})_2$  absorber layers, *Thin Solid Films* 361–362 (2000) 514.
- [19] J.B. Mooney, S.B. Radding, Spray pyrolysis processing, *Annu. Rev. Mater. Sci.* 12 (1982) 81.
- [20] P. Jackson, D. Hariskos, E. Lotter, S. Paetel, R. Wuerz, R. Menner, W. Wischmann, M. Powalla, New world record efficiency for  $\text{Cu}(\text{In,Ga})\text{Se}_2$  thin-film solar cells beyond 20%, *Prog. Photovolt.* 19 (2011) 894.
- [21] S. Nishiwaki, T. Satoh, S. Hayashi, T. Negami, T. Wada, Preparation of  $\text{Cu}(\text{In,Ga})\text{Se}_2$  thin films from  $\text{In-Ga-Se}$  precursors for high-efficiency solar cells, *J. Mater. Res.* 14 (12) (1999) 4514.
- [22] T. Mise, T. Nakada, Microstructural properties of  $(\text{In,Ga})_2\text{Se}_3$  precursor layers for efficient CIGS thin-film solar cells, *Sol. Energy Mater. Sol. Cells* 93 (2009) 1000.
- [23] A. Likforman, D. Carre, R. Hillel, Structure crystalline du seleniure d'indium  $\text{In}_2\text{Se}_3$ , *Acta Crystallogr. B* 34 (1978) 1.
- [24] K. Kambas, C. Julien, M. Jouanne, A. Likforman, M. Guittard, Raman spectra of alpha  $\alpha$ - and  $\gamma$ - $\text{In}_2\text{Se}_3$ , *Phys. Status Solidi B* 124 (1984) K105.
- [25] R. Lewandowska, R. Bacewicz, J. Filipowicz, W. Paszkowicz, Raman scattering in  $\alpha$ - $\text{In}_2\text{Se}_3$  crystals, *Mater. Res. Bull.* 36 (2001) 2577.
- [26] I. Watanabe, T. Yamamoto, Electrical and structural properties of amorphous  $\text{In-Se}$  films prepared by flash evaporation, *Jpn. J. Appl. Phys.* 24 (1985) 1282.
- [27] S. Marsillac, A.M. Combat-Marie, J.C. Bernede, A. Conan, Experimental evidence of the low-temperature formation of  $\gamma$ - $\text{In}_2\text{Se}_3$  thin films obtained by solid-state reaction, *Thin Solid Films* 288 (1996) 14.
- [28] J.F. Moulder, C.D. Wagner, W.M. Riggs, L.E. Davis, Handbook of X-ray Photoelectron Spectroscopy, Perkin-Elmer Corporation, Minnesota, 1979.
- [29] J.C. Vigié, J. Spitz, Chemical vapor deposition at low temperatures, *J. Electrochem. Soc.: Solid-State Technol.* 122 (4) (1975) 585.
- [30] S. Ishizuka, A. Yamada, P. Fons, S. Niki, Texture and morphology variation in  $(\text{In,Ga})_2\text{Se}_3$  and  $\text{Cu}(\text{In,Ga})\text{Se}_2$  thin films grown with various Se source conditions, *Prog. Photovolt. Res. Appl.* 21 (2011) 544.
- [31] N. Barreau, T. Painchaud, F. Couzinié-Devy, L. Arzel, J. Kessler, Recrystallization of CIGSe layers grown by three-step process: a model based on grain boundary migration, *Acta Mater.* 58 (2010) 5572.
- [32] N. Barreau, J.C. Bernède, H. El Maliki, S. Marsillac, X. Castel, J. Pinel, Recent studies on  $\text{In}_2\text{S}_3$  containing oxygen thin films, *Solid State Commun.* 122 (2002) 445.
- [33] D. Cahen, R. Noufi, Defect chemical explanation for the effect of air anneal on  $\text{CdS}/\text{CuInSe}_2$  solar cell performance, *Appl. Phys. Lett.* 54 (1989) 558.
- [34] L. Kronik, D. Cahen, Effects of sodium on polycrystalline  $\text{Cu}(\text{In,Ga})\text{Se}_2$  and its solar cell performance, *Adv. Mater.* 10 (1998) 31.
- [35] R. Hunger, T. Schulmeyer, A. Klein, W. Jaegermann, M.V. Lebedev, K. Sakurai, S. Niki, XPS investigation of the Cd partial electrolyte treatment of  $\text{CuInSe}_2$  absorbers, *Thin Solid Films* 480–481 (2005) 218.
- [36] H. Maki, T. Ikoma, I. Sakaguchi, N. Ohashi, H. Haneda, J. Tanaka, N. Ichinose, Control of surface morphology of  $\text{ZnO}$  (000-1) by hydrochloric acid etching, *Thin Solid Films* 411 (2002) 91.